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4/5/02**OFFICIAL**Response Under 37 C.F.R. § 1.116  
Expedited Procedure  
Examining Group 1765**PATENT**

Docket No. 150.0056 0102

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): Whonchee Lee et al.	)	Group Art Unit:	1765
	)		
Serial No.: 09/560,268	)	Examiner:	Deo, Duy Vu
Confirmation No.: 2517	)		
	)		
Filed: 26 April 2000	)		
	)		
For:		COMPOSITION FOR SELECTIVELY ETCHING AGAINST COBALT SILICIDE (As Amended)	

**RESPONSE UNDER 37 C.F.R. § 1.116**Assistant Commissioner for Patents  
**BOX AF**  
Washington D.C. 20231

Dear Sir:

In response to the Office Action dated 4 February 2002, please consider the following remarks:

**Remarks**

The Office Action dated 4 February 2002 has been received and reviewed. The pending claims are claims 64-93. Reconsideration and withdrawal of the rejections are respectfully requested.

**The 35 U.S.C. § 103(a) Rejection**

The Examiner rejected claims 64-93 under 35 U.S.C. § 103(a) as being unpatentable over Tsai et al. (U.S. Patent No. 5,486,266) in view of Thiel (U.S. Patent No. 4,316,765). Applicants